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AF/1762 IFW  
Docket No.: 8733.565.00-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Yun-Ho Jung

Application No.: 10/025,907

Art Unit: 1762

Filed: December 26, 2001

Examiner: M. Padgett

For: APPARATUS AND METHOD OF  
CRYSTALLIZING AMORPHOUS SILICON

Confirmation No.: 7489

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated April 12, 2004, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.